



US 20090244970A1

(19) **United States**

(12) **Patent Application Publication**
Rao

(10) **Pub. No.: US 2009/0244970 A1**

(43) **Pub. Date: Oct. 1, 2009**

(54) **RANDOM ACCESS MEMORY WITH CMOS-COMPATIBLE NONVOLATILE STORAGE ELEMENT AND PARALLEL STORAGE CAPACITOR**

Publication Classification

(51) **Int. Cl.**
G11C 14/00 (2006.01)
G11C 11/24 (2006.01)
(52) **U.S. Cl.** **365/185.08; 365/149**

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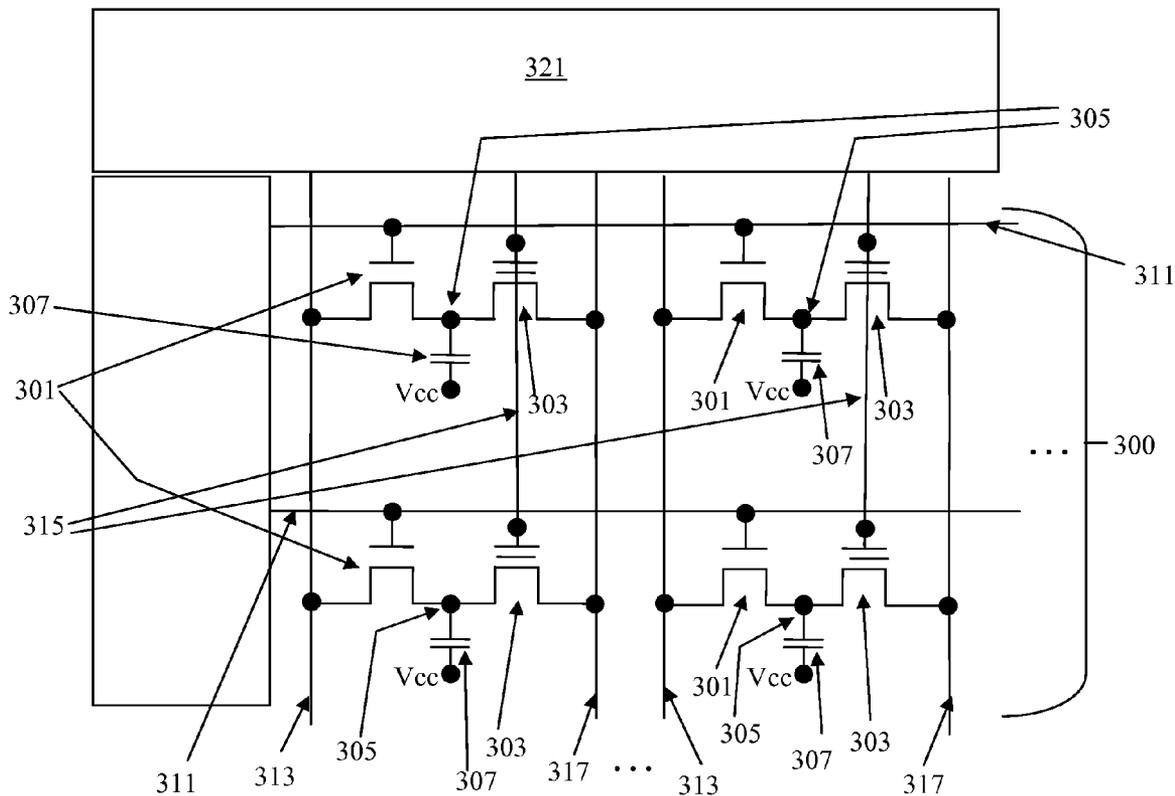
(57) **ABSTRACT**

Systems, methods, and memory device with row lines and column lines arranged in a matrix configuration with a memory cell coupled to one of the column lines and one of the row lines. The memory cell includes a storage capacitor with a first plate coupled to a storage node, a CMOS-compatible non-volatile storage element having a node coupled to the storage node and configured to hold a charge corresponding to a binary value, and an access transistor coupled to the storage node. The access transistor includes a word line gate, a first node, and a second node, the word line gate being coupled to the one of the plurality of row lines, the first node being coupled to the one of the plurality of column lines, the second node being coupled to the storage node and to said node of the CMOS-compatible non-volatile storage element.

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(21) **Appl. No.: 12/054,973**

(22) **Filed: Mar. 25, 2008**



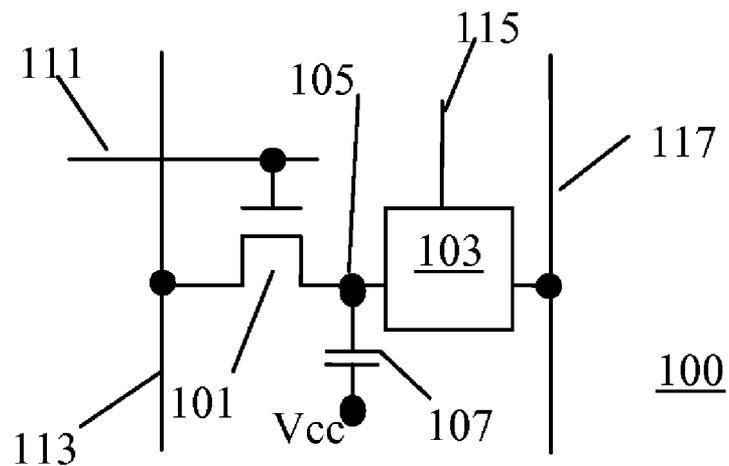


Figure 1

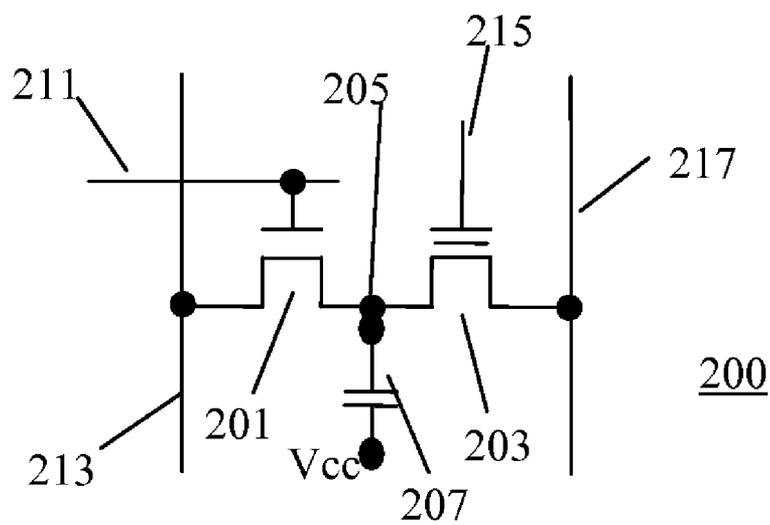


Figure 2

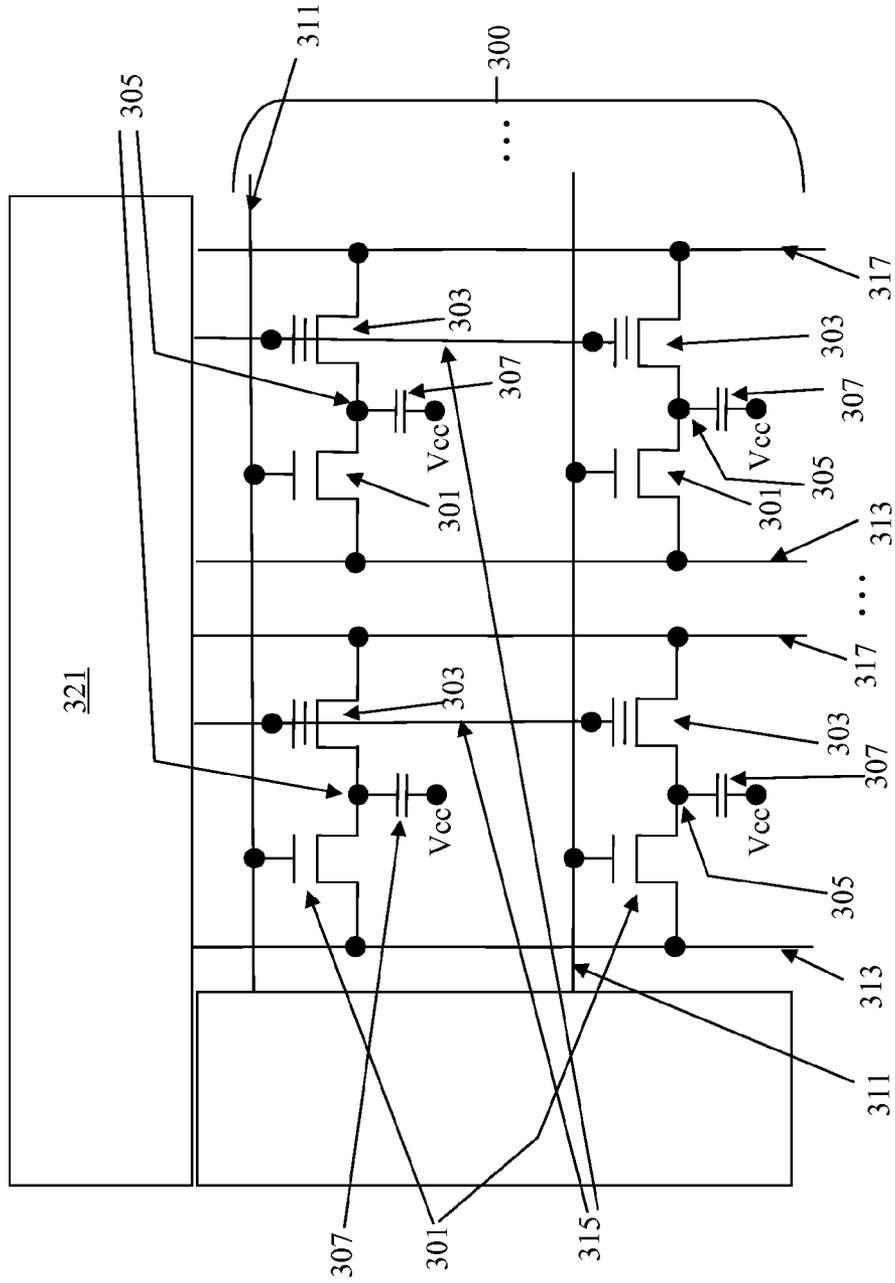


Figure 3

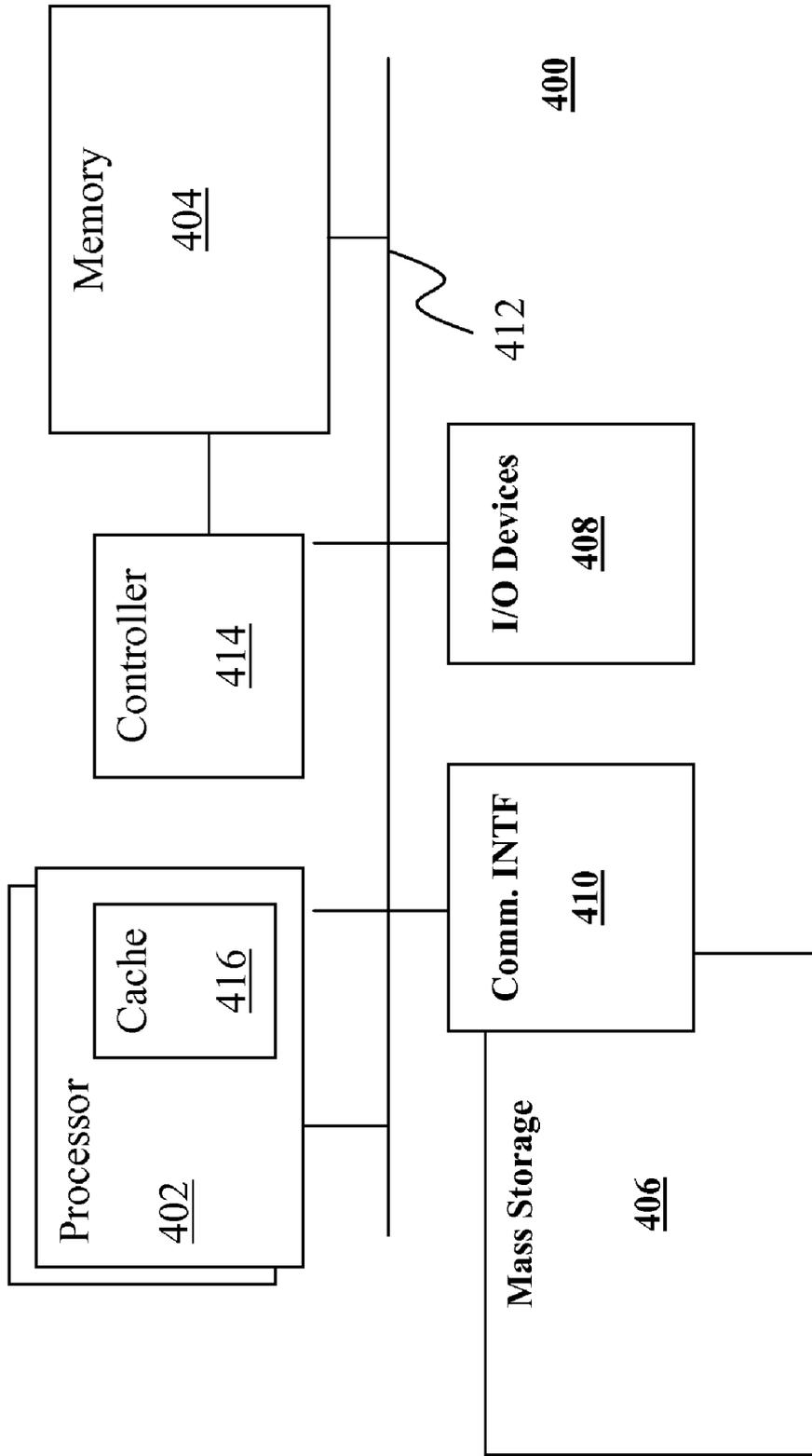


Fig. 4

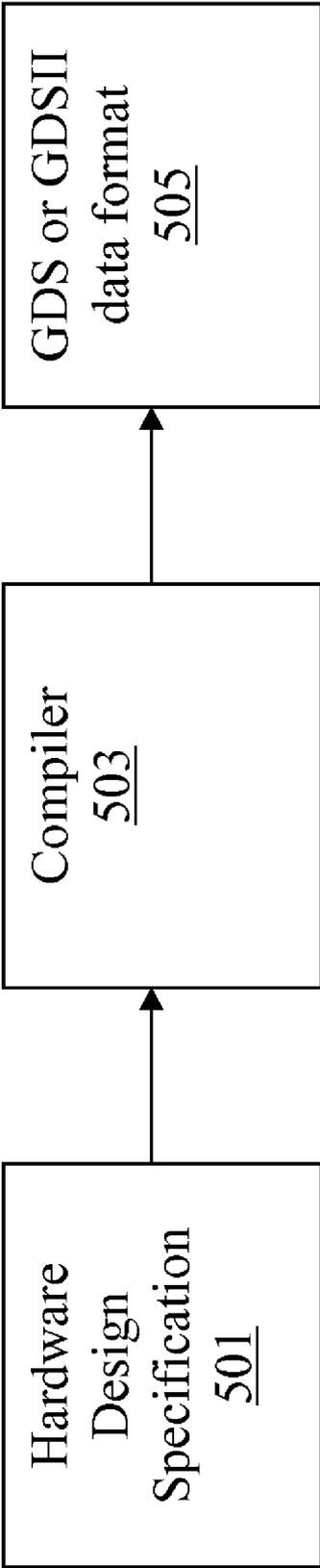


Fig. 5

**RANDOM ACCESS MEMORY WITH
CMOS-COMPATIBLE NONVOLATILE
STORAGE ELEMENT AND PARALLEL
STORAGE CAPACITOR**

TECHNICAL FIELD

[0001] Embodiments of the disclosure relate to the field of electronic circuits. In particular to digital memories having CMOS-Compatible Nonvolatile Storage Elements with parallel storage capacitors and random access memory characteristics.

BACKGROUND

[0002] Standard DRAM utilizes a capacitor to store a charge. Advantages include fast read and true random access, but the device is volatile and requires refresh to maintain the stored charge. U.S. Pat. Nos. 5,995,409 and 6,222,216 describe DRAM with contiguous memory space dedicated to nonvolatile storage. This is accomplished by “shorting” capacitors to either “1” or “0” to provide nonvolatile—but not reprogrammable—digital memory.

[0003] Flash memory provides one type of reprogrammable non-volatile memory. Flash memory read times are relatively slow due to limitations of the floating-gate transistor—or split-channel floating-gate transistor—that forms the basis for the flash memory cell. In standard flash, in order to properly engineer the floating-gate transistor for write and erase, the transistor regions are heavily doped. This creates a high threshold voltage (approximately 1V) relative to the power supply voltage in current art (approximately 1.8V), across the drain and source. This relatively high threshold voltage is needed to avoid “unintended disturbances” in unselected nonvolatile memory cells. When 1.5V (approximately) is applied to the control gate to select the transistor, the amount of current from source to drain is accordingly relatively low, and it therefore takes a relatively long time for the circuit to drive the bit line connected to the floating-gate transistor. Thus, the time required to sense the current—which corresponds to the stored charge—is longer than sensing times in standard DRAM, for example. This challenge is further complicated and worsened for device and circuit optimization as nonvolatile memory systems demand multilevel storage (instead of 1-bit binary only).

[0004] Split-channel flash (developed in the 1980s) utilizes a split-channel floating-gate transistor to provide reprogrammable non-volatile memory, but these have numerous limitations such as requiring source-side programming and the slower read times of Flash memory. It must also be activated and read simultaneously.

BRIEF DESCRIPTION OF THE DRAWINGS

[0005] Embodiments will be readily understood by the following detailed description in conjunction with the accompanying drawings. Embodiments of the disclosure are illustrated by way of example and not by way of limitation in the figures of the accompanying drawings.

[0006] FIG. 1 illustrates a Random Access Memory cell with CMOS-Compatible Nonvolatile Storage Element and parallel storage capacitor in accordance with various embodiments;

[0007] FIG. 2 illustrates a Random Access Memory cell with a floating-gate transistor storage element and parallel storage capacitor in accordance with various embodiments;

[0008] FIG. 3 illustrates Random Access Memory cell array with access circuitry and memory cells having CMOS-Compatible Nonvolatile Storage Elements and parallel storage capacitors in accordance with various embodiments;

[0009] FIG. 4 illustrates a computing system including a memory device with memory cells having CMOS-Compatible Nonvolatile Storage Elements and parallel storage capacitors in accordance with various embodiments; and

[0010] FIG. 5 shows a block diagram of a hardware design specification being compiled into GDS or GDSII data format in accordance with various embodiments.

DETAILED DESCRIPTION OF EMBODIMENTS

[0011] In the following detailed description, reference is made to the accompanying drawings which form a part hereof, and in which are shown by way of illustration embodiments in which the disclosure may be practiced. It is to be understood that other embodiments may be utilized and structural or logical changes may be made without departing from the scope of the disclosure. Therefore, the following detailed description is not to be taken in a limiting sense, and the scope of embodiments is defined by the appended claims and their equivalents.

[0012] Various operations may be described as multiple discrete operations in turn, in a manner that may be helpful in understanding embodiments; however, the order of description should not be construed to imply that these operations are order dependent. Also, embodiments may have fewer operations than described. A description of multiple discrete operations should not be construed to imply that all operations are necessary.

[0013] The terms “coupled” and “connected,” along with their derivatives, may be used. It should be understood that these terms are not intended as synonyms for each other. Rather, in particular embodiments, “connected” may be used to indicate that two or more elements are in direct physical or electrical contact with each other. “Coupled” may mean that two or more elements are in direct physical or electrical contact. However, “coupled” may also mean that two or more elements are not in direct contact with each other, but yet still cooperate or interact with each other.

[0014] For the purposes of the description, a phrase in the form “A/B” means A or B. For the purposes of the description, a phrase in the form “A and/or B” means “(A), (B), or (A and B)”. For the purposes of the description, a phrase in the form “at least one of A, B, and C” means “(A), (B), (C), (A and B), (A and C), (B and C), or (A, B and C)”. For the purposes of the description, a phrase in the form “(A)B” means “(B) or (AB)” that is, A is an optional element.

[0015] The description may use the phrases “in an embodiment,” or “in embodiments,” which may each refer to one or more of the same or different embodiments. Furthermore, the terms “comprising,” “including,” “having,” and the like, as used with respect to embodiments, are synonymous.

[0016] Embodiments may include memory devices and systems with memory cells comprising an access transistor in series with a CMOS-compatible non-volatile storage element and parallel storage capacitor. The CMOS-compatible non-volatile storage element may be Magnetoresistive Random Access Memory (MRAM) cell, Phase-change memory (PCM) cell, or floating-gate transistor (e.g. a Flash memory cell) in various embodiments. The storage capacitor, CMOS-compatible non-volatile storage element, and a node of the access transistor may all be coupled to a common storage

node within the memory cell. Embodiments may provide fast read on par with dynamic random access memory (DRAM) along with the non-volatility of Flash. In embodiments, stored charges may be erased one bit at a time, unlike in typical Flash. Also, unlike split-channel flash memory which requires source-side erase leading to potential disturbances of neighboring cells, embodiments may utilize “drain side” erasing. Finally, during a read operation, the CMOS-compatible non-volatile storage element may be activated and the resulting voltage may be held by the storage capacitor for a period of time, typically several milliseconds. At some later time, the access transistor may be activated to sense the held voltage. This decoupling of the activation and access operations, which may be made possible by the parallel storage capacitor, may allow greater flexibility in the operation of the memory circuit.

[0017] In standard flash memory, in order to properly engineer the floating-gate transistor for write and erase, the transistor regions are heavily doped. This creates a high threshold voltage (approximately 1V) across the drain and source. When 1.5V is applied to the control gate of the floating-gate transistor to select the transistor (e.g. a typical word line voltage), the amount of current from source to drain is relatively low, and it takes a relatively long time to drive the bit line; thus, read times are slow. Also, because the floating-gate transistor is engineered for write operations, read times are slow not only relative to the read times in other types of memory, but also slower than the write times on the same flash memory device.

[0018] Embodiments may include access circuitry coupled to a plurality of memory cells. The access circuitry may be configured to activate the CMOS-compatible non-volatile storage element at a first time in order to generate a voltage on the common storage node. The generated voltage may correspond to a binary value stored within the CMOS-compatible non-volatile storage element. A first plate of the storage capacitor connected to the common storage node may be configured to substantially hold the voltage for a period of time, up to several milliseconds. For example, a typical DRAM capacitor practiced in the art today may be configured to hold a voltage for approximately 16 ms. The access circuitry may then be configured to activate the access transistor at a second time later than the first time, and sense the held voltage on a column line attached to the access transistor. The difference between the first and second times may be less than or equal to the period of time that the storage capacitor is configured to substantially hold the voltage. In embodiments, this may allow the access circuitry to decouple the activating of the CMOS-compatible non-volatile storage element from the activating of the access transistor. Therefore—unlike the memory cell and device described in U.S. patent application Ser. No. 12/053,976—the word line may not need to be simultaneously activated along with the CMOS-compatible non-volatile storage element and the stored voltage may be sensed at a later time. The access circuitry may therefore be configured to perform simultaneous operations on parallel memory cells (those connected to the same word line), thereby providing additional flexibility in the timing and accessing of memory cells within the memory device.

[0019] U.S. patent application Ser. No. 12/053,976 describes a digital memory cell with an access transistor in series with a CMOS-compatible non-volatile storage element, most notably a floating-gate transistor. That application describes a reprogrammable, non-volatile memory device

with true random access characteristics. Sensing of the stored value has to occur at the same time as the floating-gate transistor is activated. Meanwhile, all other memory cells in parallel to the cells being accessed (i.e. those on the same word line) have to be held “quiet” during this read operation.

[0020] In embodiments disclosed herein, the same engineering principles from standard Flash may apply to the floating-gate transistor, but read times may be faster. Adding the access transistor and the parallel storage capacitor may allow voltages to be sensed, similar to standard DRAM, as opposed to the currents that must be sensed in Flash memory. Thus, read times may be faster than Flash and may be more on par with standard DRAM while providing a reprogrammable and non-volatile memory device.

[0021] FIG. 1 illustrates a memory cell 100 with CMOS-Compatible Nonvolatile Storage Element 103 and parallel storage capacitor in accordance with various embodiments. Access transistor 101 may be arranged in series with CMOS-Compatible Nonvolatile Storage Element 103 with storage node 105 between them. A first plate of storage capacitor 107 may be coupled to storage node 105. A second plate of storage capacitor 107 may be held at a constant voltage, such as for example a power supply voltage. CMOS-compatible non-volatile storage element 103 may be configured to hold a charge corresponding to a stored binary value. In embodiments, the stored binary value may be an n-bit binary value, such as for example a 2-bit binary value. Access transistor 101 may have a word line gate connected to row line 111 and a first node connected to column line 113. In embodiments, storage node 105 may be connected to a second node of access transistor 101. CMOS-Compatible Nonvolatile Storage Element 103 may be connected to control line 115 and drain line 117. In embodiments, an array of memory cells 100 may be arranged in a plurality of rows and columns connected by plurality of row lines 111 and column lines 113. Access circuitry may be coupled to the row lines 111, column lines 113, control lines 115, and drain lines 117 to perform access operations on the various memory cells 100 such as, for example, read, write, and erase operations. Such access circuitry may be configured to receive memory addresses and access commands and perform access operations on those memory cells 100 identified by the received addresses.

[0022] In embodiments, CMOS-compatible non-volatile storage element 103 may be a Magnetoresistive Random Access Memory (MRAM) cell, Phase-change memory (PCM) cell, or floating-gate transistor (e.g. a flash memory cell).

[0023] FIG. 2 illustrates Random Access Memory cell 200 with floating-gate transistor 203 and parallel storage capacitor 207 in accordance with various embodiments. Access transistor 201 may be arranged in series with floating-gate transistor 203 with storage node 205 between them. A first plate of storage capacitor 207 may be coupled to storage node 205 and a second plate may be held at a constant potential, such as for example a supply voltage. A floating-gate of floating-gate transistor 203 may be configured to hold a charge corresponding to a stored binary value. In embodiments, the stored binary value may be an n-bit binary value, such as for example a one or two-bit binary value. Access transistor 201 may have a word line gate connected to row line 211 and a first node connected to column line 213. In embodiments, storage node 205 may be connected to a source node of floating-gate transistor 203. In embodiments, floating-gate

transistor **203** may have a control gate connected to control line **215** and a drain node connected to drain line **217**.

[0024] In embodiments, during a read operation, access circuitry (not shown) may be configured to set a select voltage on select line **215** and drain line **217** at a first time. In embodiments, the select voltage may be the same as a supply voltage such as for example, 3.3V, 1.5V, 1.8V, 1.0V, or other voltage. Embodiments are not limited to any particular supply or select voltages. In n-channel floating gate nonvolatile memory transistors, negative charges (electrons) may be stored on the floating gate of a floating-gate transistor to program the transistor. If a negative charge has been previously stored on the floating-gate of floating-gate transistor **203**, then the select voltage on select line **215**—and therefore on the select gate—may be “masked” (neutralized or compensated) by the stored negative charge on the floating-gate transistor. In that case, the floating-gate transistor may not be activated and no voltage may be applied on storage node **205**. By contrast, if no negative charge has been previously stored on the floating-gate—or if such a stored negative charge has been subsequently erased—then there will be no masking of the select voltage and a voltage may be applied on storage node **205**. The first plate of storage capacitor **207** may be configured to hold the applied charge on storage node **205** for a period of time, up to several milliseconds. For example, a typical DRAM capacitor practiced in the art today may be configured to hold a voltage for 16 ms, or other time period.

[0025] In embodiments, a stored negative charge on the floating-gate may indicate a binary “0” and the access circuitry may be configured to associate a low sensed voltage to a binary “0”. In other words, the access circuitry may be configured to associate a sensed voltage falling within a relatively low range of voltage to a binary “0”. The access circuitry may also be configured to associate a larger sensed voltage to a binary “1”. In other words, the access circuitry may be configured to associate a sensed voltage falling within a relatively high range of voltage to a binary “1”. In embodiments where the stored charge on the floating-gate transistor corresponds with an n-bit binary number, where n is greater than 1, the access circuitry may be configured to sense any of 2^n voltage ranges and associate each with a different n-bit binary stored value. In such embodiments, the level of sensed voltage may be determined by a magnitude of the stored charge within the floating-gate transistor.

[0026] In embodiments, the floating-gate transistor may be configured to be written or programmed by either Fowler-Nordheim tunneling or hot electron injection, both of which are well-known in the art. Embodiments are not limited by any writing or programming techniques. The access circuitry (not shown) may be configured in embodiments to perform a write or program operation. In embodiments, the access circuitry may be configured to set column line **213** to 0V, row line **211** to a select voltage, and control line **215** and drain line **217** to a program voltage to write to the floating-gate. In embodiments, the program voltage may be greater than a supply voltage and the select voltage may be equal to, or nearly equal to, the supply voltage. In embodiments, the program voltage may be between 6V to 8V, or other voltage.

[0027] During an erase operation, the access circuitry (not shown) may be configured, in embodiments, to set column line **213** to ground, row line **211** to a select voltage, and drain line **217** to an erase voltage. In embodiments, the erase voltage may be greater than a supply voltage, and the select voltage may be equal to the supply voltage. This may result in

a “drain-side” erase. Alternatively, the access circuitry may be configured to perform a “source-side” erase.

[0028] The above embodiments may apply to n-channel floating-gate transistors; hence the positive voltages. The same concepts may apply equally to p-channel floating-gate transistors utilizing negative voltages. Also, in embodiments, a stored charge on the floating-gate of the floating-gate transistor may correspond to a binary “0”, but may correspond to a binary “1” in other embodiments. Embodiments are not limited to n-channel or p-channel transistors.

[0029] FIG. 3 illustrates Random Access Memory cell array **300** with access circuitry **321** and CMOS-Compatible Nonvolatile Storage Elements **303** with parallel storage capacitors **307** in accordance with various embodiments. Array **300** may include a plurality of row lines **311** and a plurality of column lines **313** arranged in a matrix configuration. Although array **300** is shown with only two column lines and two row lines—including four memory cells—many more row lines, column lines, and memory cells in various configurations may be possible in various embodiments. Embodiments are not limited to any particular array size or sizes.

[0030] Access circuitry **321** may be coupled to the plurality of row lines **311**, the plurality of column lines **313**, the plurality of control lines **315**, and the plurality of drain lines **317**. In embodiments, access circuitry **321** may be configured to set one or more of the plurality of row lines **311** to a select voltage to select a particular row or rows of memory cells to be read, written, or erased. In a read operation, in embodiments, access circuitry **321** may be configured to set one or more control lines **315** to the select voltage and one or more drain lines **317** to a read voltage at a first time and a control line **315** connected to the control gate of access transistors **301** at a second time later than the first time and sense the voltage held by storage capacitor **307** on one of column lines **313**. In embodiments, access circuitry **321** may be configured to ensure that a difference between the first time and the second time is less than or equal to the period of time that storage capacitors **307** are configured to substantially hold the voltage, so that the voltage can be properly sensed by the access circuitry without errors. In embodiments, access circuitry **321** may be configured to select one or more memory cells for erasing and/or programming, as described in more detail above in relation to FIG. 2. In embodiments, access circuitry **321** may be configured to select a single word or memory cell for erase.

[0031] In embodiments, the binary value corresponding to a stored charge may comprise n-bits and the voltage sensed during a read operation may comprise 2^n possible voltage ranges. In such embodiments, access circuitry **321** may be configured to sense the voltage and determine which of 2^n voltage ranges the sensed voltage matches at a point in time. In embodiments, access circuitry **321** may be configured to perform simultaneous operations on other memory cells connected to the same row line **311** as the memory cell with the activated floating-gate transistor prior to activating access transistor **301**. Such operations may include read, write, or erase operations in embodiments.

[0032] FIG. 4 illustrates a computing system including a memory device with CMOS-Compatible Nonvolatile Storage Elements in accordance with various embodiments. As shown, computing system/device **400** may include one or more processors **402**, and system memory **404**. System memory **404** may be imbued with the teachings of one or

more embodiments as described within this specification. In particular, system memory **404** may include one or more memory cells including CMOS-Compatible Nonvolatile Storage Elements with parallel storage capacitors. In embodiments, such CMOS-Compatible Nonvolatile Storage Elements may be a floating-gate transistor. In embodiments, it may be a Magnetoresistive Random Access Memory (MRAM) cell or a Phase-change memory (PCM) cell. System memory **404** may also include access circuitry configured to operate in one or more ways compatible with embodiments described elsewhere within this specification.

[0033] Additionally, computing system/device **400** may include mass storage devices **406** (such as diskette, hard drive, CDROM, flash memory, and so forth), input/output devices **408** (such as keyboard, cursor control and so forth) and communication interfaces **410** (such as network interface cards, modems and so forth). The elements may be coupled to each other via system bus **412**, which represents one or more buses. In the case of multiple buses, they may be bridged by one or more bus bridges (not shown). Finally, controller **414** may be included and configured to operate memory **404** in accordance with embodiments.

[0034] In embodiments, one or more processors **402** may include memory cache **416**. Other than the teachings of the various embodiments of the present invention, each of the elements of computer system/device **400** may perform its conventional functions known in the art. In particular, system memory **404** and mass storage **406** may be employed to store a working copy and a permanent copy of programming instructions implementing one or more software applications.

[0035] Although FIG. 4 depicts a computer system, one of ordinary skill in the art will recognize that embodiments of the disclosure may be practiced using other devices that utilize RAM or other types of digital memory such as, but not limited to, mobile telephones, Personal Data Assistants (PDAs), gaming devices, high-definition television (HDTV) devices, appliances, networking devices, digital music players, laptop computers, portable electronic devices, telephones, as well as other devices known in the art.

[0036] In various embodiments, the earlier-described memory cells are embodied in an integrated-circuit. Such an integrated-circuit may be described using any one of a number of hardware-design-languages, such as but not limited to VHSIC hardware-description-language (VHDL) or Verilog. The compiled design may be stored in any one of a number of data format, such as but not limited to GDS or GDS II. The source and/or compiled design may be stored on any one of a number of medium such as but not limited to DVD.

[0037] FIG. 5 shows a block diagram depicting the compilation of a hardware design specification **501** which may be run through compiler **503** producing GDS or DGSII data format **505** describing an integrated circuit in accordance with various embodiments.

[0038] Although certain embodiments have been illustrated and described herein for purposes of description of the preferred embodiment, it will be appreciated by those of ordinary skill in the art that a wide variety of alternate and/or equivalent embodiments or implementations calculated to achieve the same purposes may be substituted for the embodiments shown and described without departing from the scope of the present invention. Those with skill in the art will readily appreciate that embodiments in accordance with the disclosure may be implemented in a very wide variety of ways. This application is intended to cover any adaptations or variations

of the embodiments discussed herein. Therefore, it is manifestly intended that embodiments in accordance with the present invention be limited only by the claims and the equivalents thereof.

1. A memory device for non-volatile storage, comprising:
 - a plurality of row lines and a plurality of column lines arranged in a matrix; and
 - a memory cell coupled to one of the plurality of column lines and to one of the plurality of row lines, the memory cell comprising:
 - a storage capacitor comprising a first plate coupled to a storage node;
 - a CMOS-compatible non-volatile storage element comprising a node coupled to the storage node, and configured to hold a charge corresponding to a binary value; and
 - an access transistor coupled to the storage node, wherein the access transistor comprises a word line gate, a first node, and a second node, wherein the word line gate is coupled to the one of the plurality of row lines, wherein the first node is coupled to the one of the plurality of column lines, and wherein the second node is coupled to the storage node and to the node of the CMOS-compatible non-volatile storage element.
2. The memory device of claim 1, further comprising access circuitry coupled to the CMOS-compatible non-volatile storage element, to the plurality of row lines, and to the plurality of column lines, wherein the access circuitry is configured to activate the CMOS-compatible non-volatile storage element at a first time, wherein the CMOS-compatible non-volatile storage element is configured, in response to activation, to apply a voltage to the storage node corresponding to the binary value, and wherein the access circuitry is further configured to set the one of the plurality of row lines to a select voltage at a second time, later than the first time, to sense the applied voltage of the storage node corresponding to the binary value, wherein the storage capacitor is configured to substantially hold the voltage applied to the storage node for a period of time, and wherein the access circuitry is configured to set an elapsed time between the first time and the second time that is equal to or less than the period of time.
3. The memory device of claim 2, wherein the binary value comprises n bits, and wherein the access circuitry is configured to determine which of 2^n voltage ranges the sensed voltage matches.
4. The memory device of claim 1, wherein the CMOS-compatible non-volatile storage element is a floating-gate-transistor comprising a source node configured as the node of the CMOS compatible non-volatile storage element that is coupled to the storage node.
5. The memory device of claim 4, wherein the memory device further comprises a drain line, and wherein the floating-gate transistor further comprises a drain node coupled to the drain line.
6. The memory device of claim 5, wherein the floating-gate transistor comprises a control gate, wherein the memory device further comprises access circuitry coupled to the plurality of row lines, the plurality of column lines, the control gate of the floating-gate transistor, and to the drain line, wherein the access circuitry is configured to drive the control gate to the select voltage to drive the drain line to a read voltage, and to apply a voltage to the storage node corre-

sponding to the binary value, and wherein the storage capacitor is configured to substantially hold the applied voltage for a period of time.

7. The memory device of claim 6, wherein the access circuitry is farther configured to drive the control gate to the select voltage and to drive the drain line to the read voltage at a first time, and wherein the access circuitry is configured to set the one of the plurality of row lines to the select voltage and to sense the held voltage on the one of the plurality of column lines at a second time later than the first time, wherein the period of time that the storage capacitor is configured to substantially hold the voltage is greater than or equal to an elapsed time between the first and second times.

8. The memory device of claim 1, wherein the CMOS-compatible non-volatile storage element is one of a Magnetoresistive Random Access Memory (MRAM) cell or a Phase-Change Memory (PCM) cell.

9. A method comprising:

setting, by access circuitry of a digital memory device at a first time, a control select voltage on a control gate of a floating-gate transistor configured to hold a charge corresponding to a binary value, wherein the floating-gate transistor is coupled to an access transistor in series, wherein the floating-gate transistor comprises a drain node coupled to a drain line and a node coupled to a storage node, wherein the storage node is coupled to a storage capacitor, wherein said setting causes a voltage to be applied to the storage node by the floating gate transistor, and wherein the storage capacitor is configured to substantially hold the voltage applied to the storage node;

fixing, by the access circuitry at a second time later than the first time a row select voltage on a row line coupled to a word line gate of the access transistor, wherein the access transistor comprises a first node coupled to a column line and a second node coupled to a storage node; and

sensing, by the access circuitry at the second time, the voltage held by the storage capacitor.

10. The method of claim 9, wherein the storage capacitor is configured to substantially hold the voltage applied to the storage node for a period of time, and wherein a difference between the first and second time is less than or equal to the period of time.

11. The method of claim 9, wherein the binary value comprises n bits and wherein the method comprises detecting which of 2^n voltage ranges the sensed held-voltage matches.

12. An apparatus comprising:

means for setting, at a first time, a control select voltage on a control gate of a floating-gate transistor configured to hold a charge corresponding to a binary value, wherein the floating-gate transistor is coupled to an access transistor in series, wherein the floating-gate transistor comprises a drain node coupled to a drain line, wherein the floating-gate transistor comprises and a node coupled to a storage node, wherein the storage node is coupled to a storage capacitor, wherein the floating-gate transistor is configured, in response to the control select voltage, to set a voltage to the storage node, and wherein the storage capacitor is configured to substantially hold the applied voltage applied at the storage node for a period of time;

means for fixing, at a second time later than the first time, a row select voltage on a row line coupled to a word line gate of the access transistor, the access transistor com-

prising a first node coupled to a column line and a second node coupled to a storage node; and
means for sensing, at the second time, the voltage on the storage node.

13. The apparatus of claim 12, wherein the storage capacitor is configured to substantially hold the voltage applied to the storage node for a period of time and wherein a difference between the first and second time is less than or equal to the period of time.

14. The apparatus of claim 12, wherein the binary value comprises n bits, and wherein the apparatus includes means for determining which of 2^n voltage ranges the sensed voltages matches.

15. A system comprising:

a digital memory device comprising:

a plurality of row lines and a plurality of column lines arranged in a matrix; and

a memory cell coupled to one of the plurality of column lines and to one of the plurality of row lines, wherein the memory cell comprises:

a storage capacitor coupled to a storage node;

a CMOS-compatible non-volatile storage element having a node coupled to the storage node, the CMOS-compatible non-volatile storage element configured to hold a charge corresponding to a binary value to store the binary value; and

an access transistor coupled to the CMOS-compatible non-volatile storage element and to the storage capacitor via the storage node, the access transistor including a word line gate, a first node, and a second node, wherein the word line gate is coupled to the one of the plurality of row lines, wherein the first node is coupled to the one of the plurality of column lines, and wherein the second node is coupled to the storage node; and

a digital memory controller configured to issue access commands to a digital memory device to selectively read or write a voltage corresponding to the binary value.

16. The system of claim 15, further comprising access circuitry coupled to the digital memory controller, to the CMOS-compatible non-volatile storage element, to the plurality of row lines, and to the plurality of column lines, wherein the access circuitry is configured to activate, in response to an access command received from the memory controller, the CMOS-compatible non-volatile storage element at a first time, and to set the one of the plurality of row lines to a row select voltage at a second time later than the first time to sense a voltage of the storage node corresponding to the binary value, wherein the CMOS-compatible non-volatile storage element is configured to drive the storage node to the voltage upon activation, and wherein the storage capacitor is configured to substantially hold the voltage driven to the storage node for a period of time greater than or equal to an elapsed time between the first and second time.

17. The system of claim 16, wherein the binary value comprises n bits, and wherein the access circuitry is configured to sense the voltage of the storage node and to determine which of 2^n voltage ranges the sensed voltage matches.

18. The system of claim 15, wherein the CMOS-compatible non-volatile storage element is a floating-gate-transistor comprising a source node wherein the source node is the node of the CMOS compatible non-volatile storage element coupled to the storage node.

19. The system of claim **18**, wherein the memory device further comprises a drain line, and wherein the floating-gate transistor further comprises a drain node coupled to the drain line.

20. The system of claim **19**, wherein the floating-gate transistor comprises a control gate, wherein the memory device further comprises access circuitry coupled to the plurality of row lines, to the plurality of column lines, to the control gate of the floating-gate transistor, and to the drain line, wherein the access circuitry is configured to drive the control gate to the-a control select voltage, to drive the drain line to a read voltage, and to read the voltage corresponding to the binary value.

21. The system of claim **20**, wherein the access circuitry is further configured to both drive the control gate to the control select voltage and to drive the drain line to the read voltage at a first time, to set the one of the plurality of row lines to the row select voltage, and to sense the voltage corresponding to the binary value on the one of the plurality of column lines at

a second time later than the first time, wherein a period of time that the storage capacitor is configured to substantially hold the voltage is greater than or equal to an elapsed time between the first and second time.

22. The system of claim **15**, wherein the CMOS-compatible non-volatile storage element is one of a Magnetoresistive Random Access Memory (MRAM) cell or a Phase-Change Memory (PCM) cell.

23. An article of manufacture, comprising a plurality of computer-readable hardware design language instructions, or compilation of the hardware design language instructions, wherein the hardware design language instructions specify an implementation of the apparatus as set forth in claim **1** as an integrated circuit.

24. The article of manufacture of claim **24**, wherein a hardware design language of the hardware design language instructions is either VHDL or Verilog.

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